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Standard tube fitting for inter-modular gas flow connection

Intra-modular gas flow connector

Knudsen pump (KP) module

Gas flow direction for vapor sampling

KP

KP

Precon-centrator

Gas flow direction for analytical separation

Column1

Column2

Gas flow direction for vapor sampling

Gas flow inlet during analytical separation

CapDet1

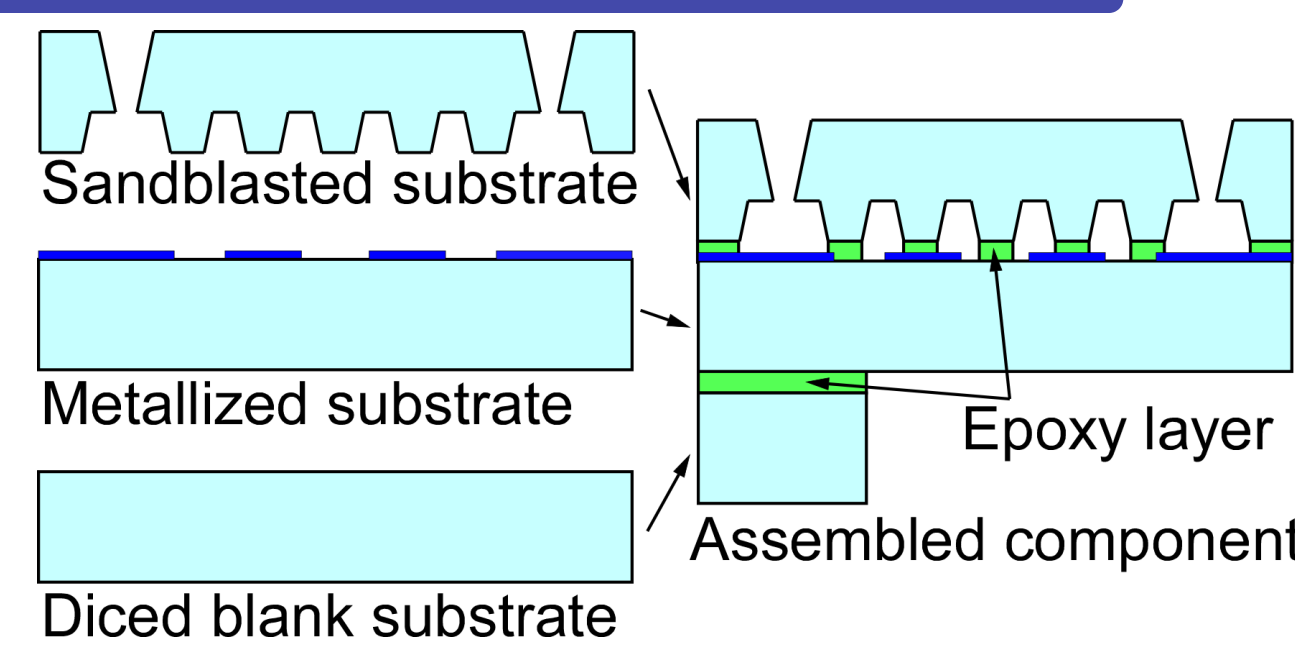
CapDet2

Gas flow inlet during vapor sampling

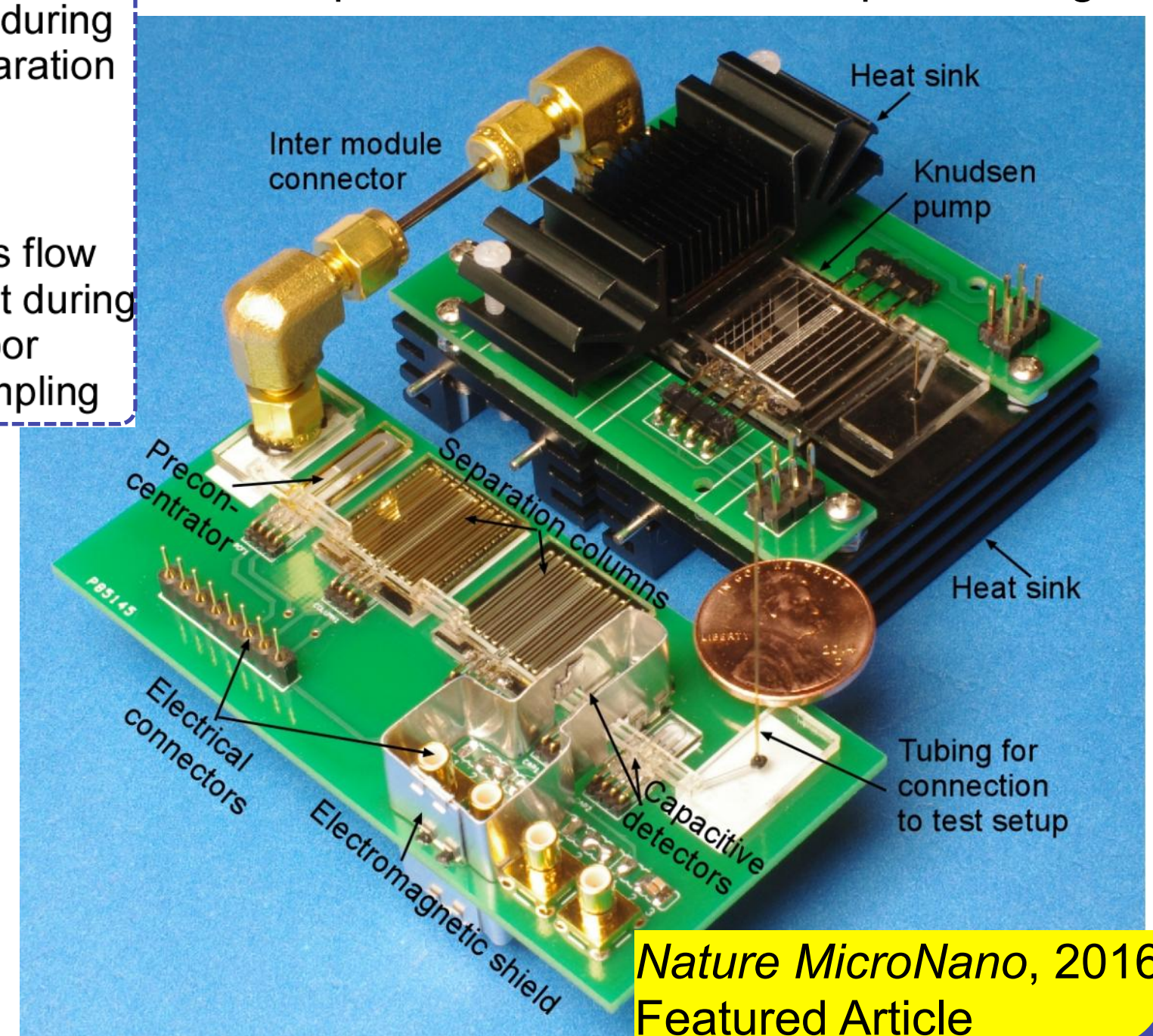
Chromatography module

Intra-modular gas flow connector

- Fully electronic
- All fluidic components microfabricated by a common low-cost, three-mask process
- Compatible with room air as carrier gas
- Complementary capacitive detectors
  - Enhance vapor recognition
  - Resolve co-eluting peaks

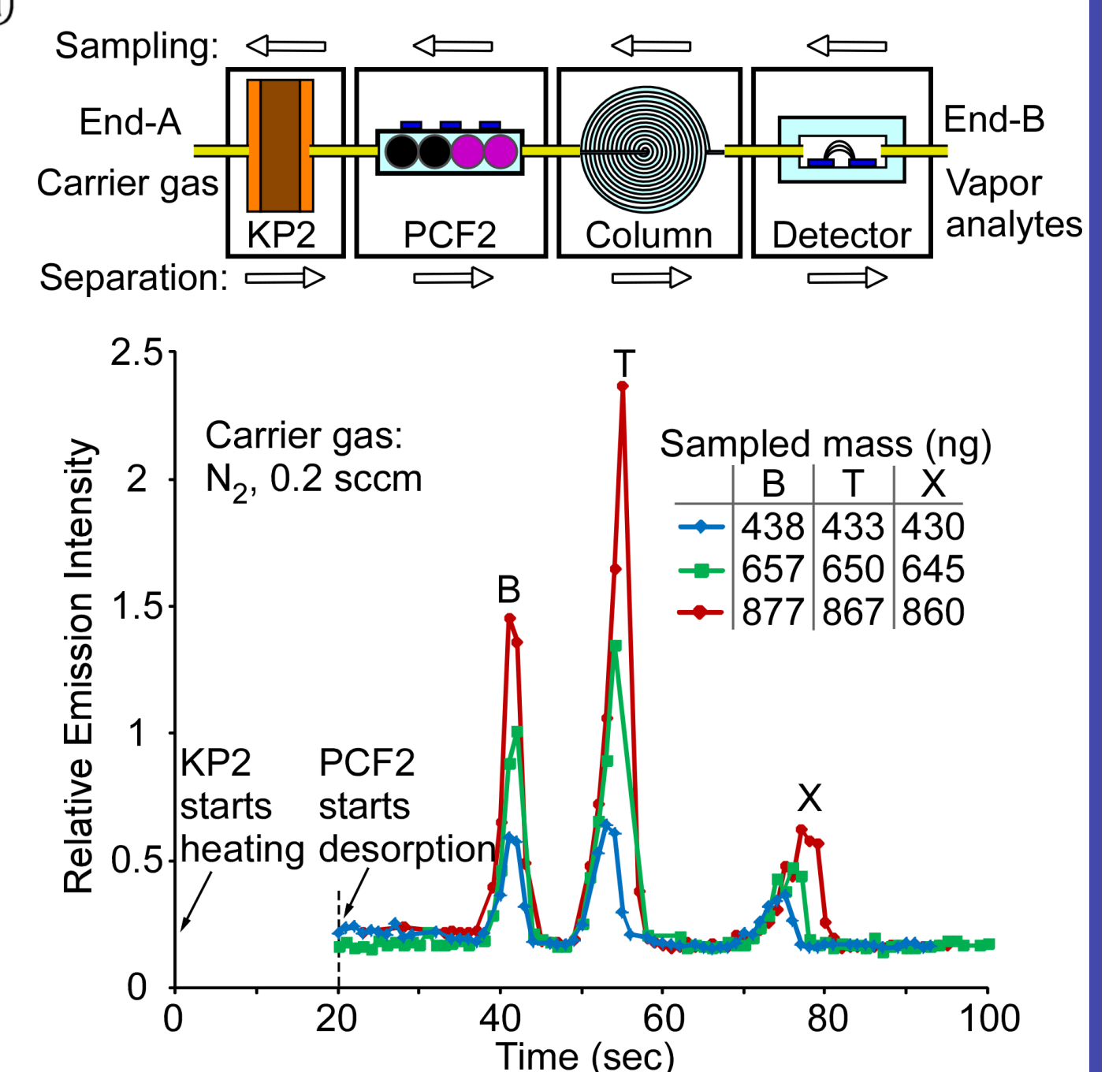
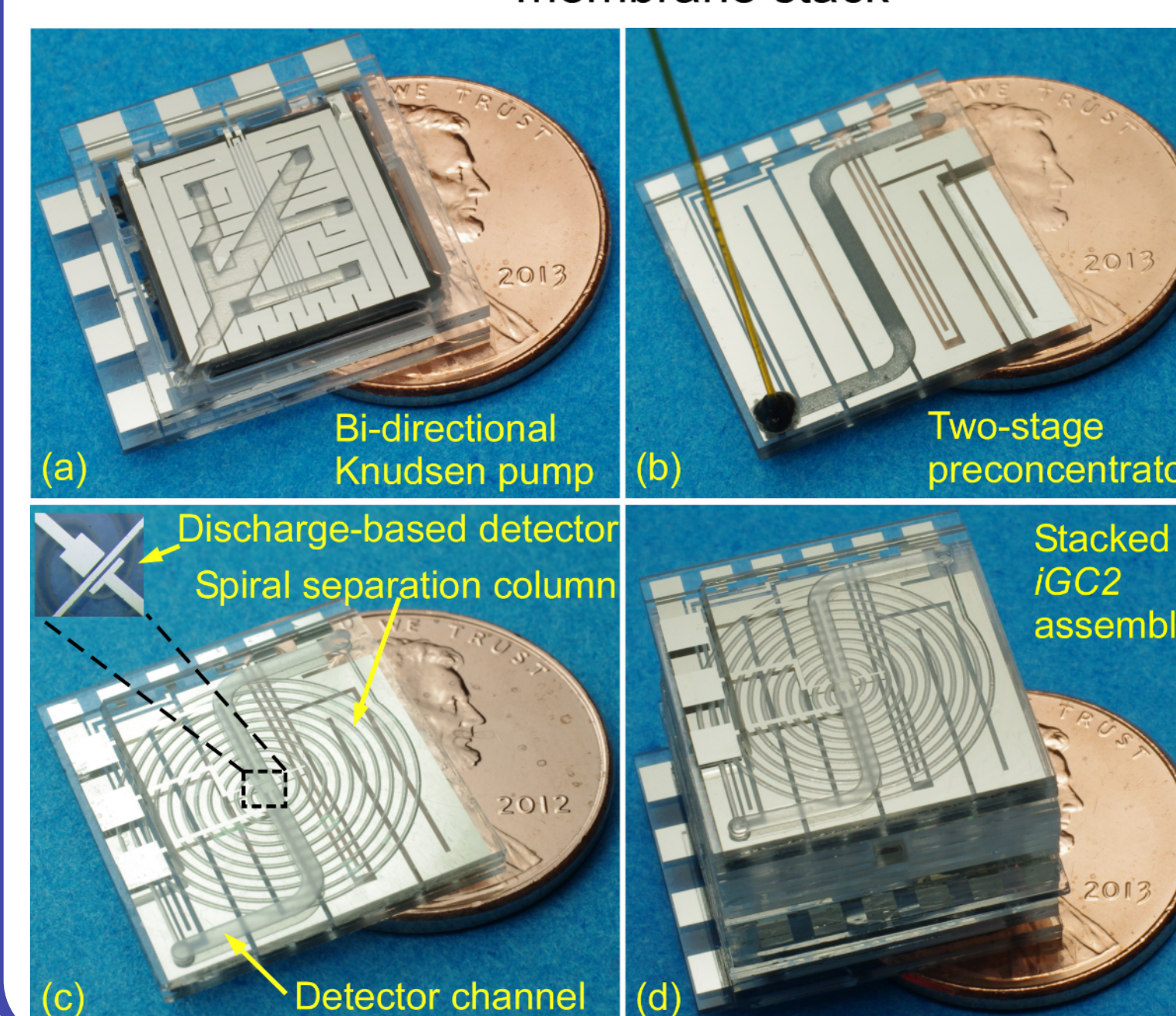


- Knudsen pump: epoxy sealing
- Column: stationary phase coating
- Preconcentrator: sorbent packing
- Capacitive detector: OV-1 spin-coating



Nature MicroNano, 2016  
Featured Article

- Bi-directional flow provided by a bi-directional pump in a valveless, 4 cm<sup>3</sup> stacked architecture
- The discharge-based detector relies on optical interface and requires carrier gas

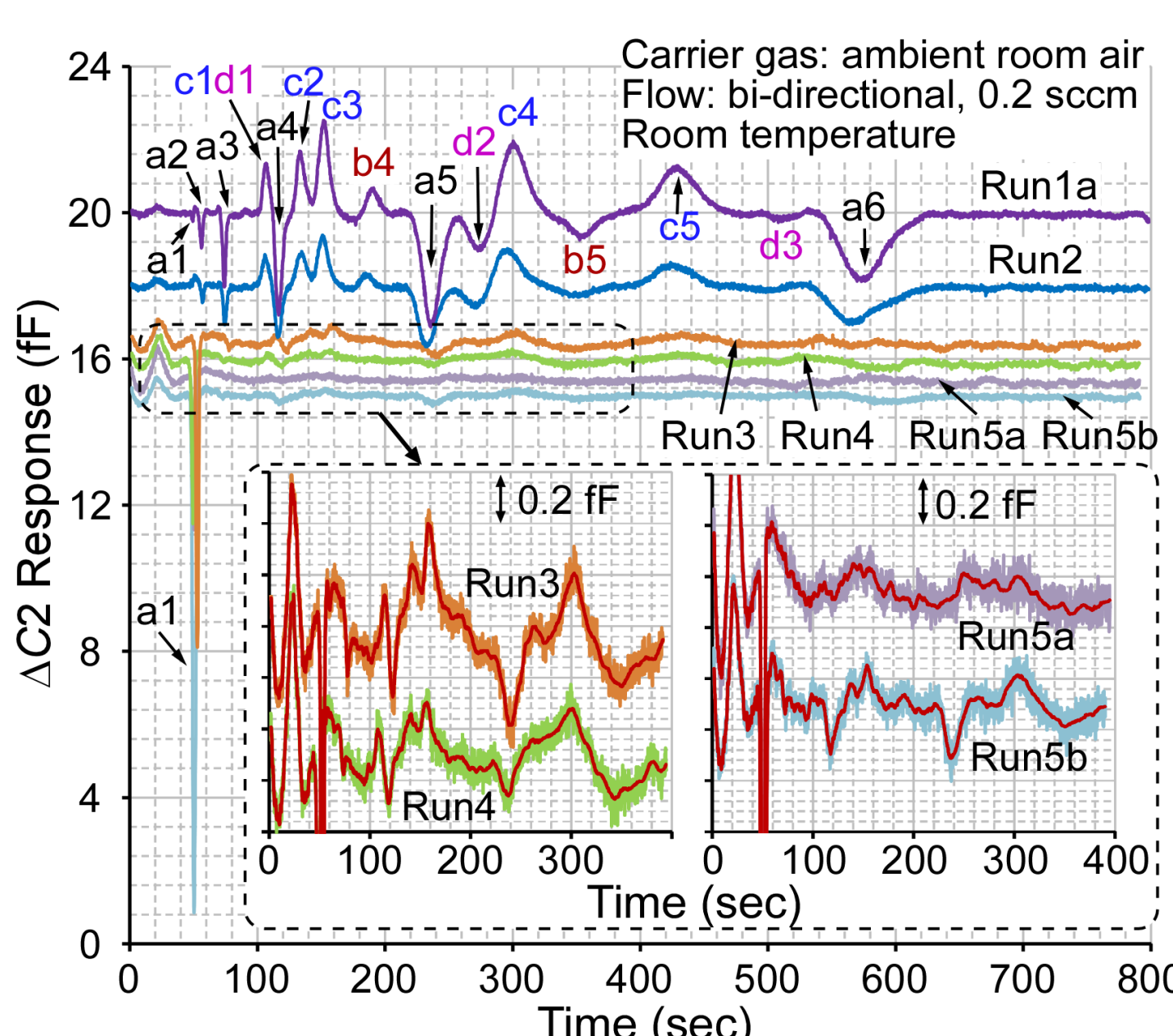
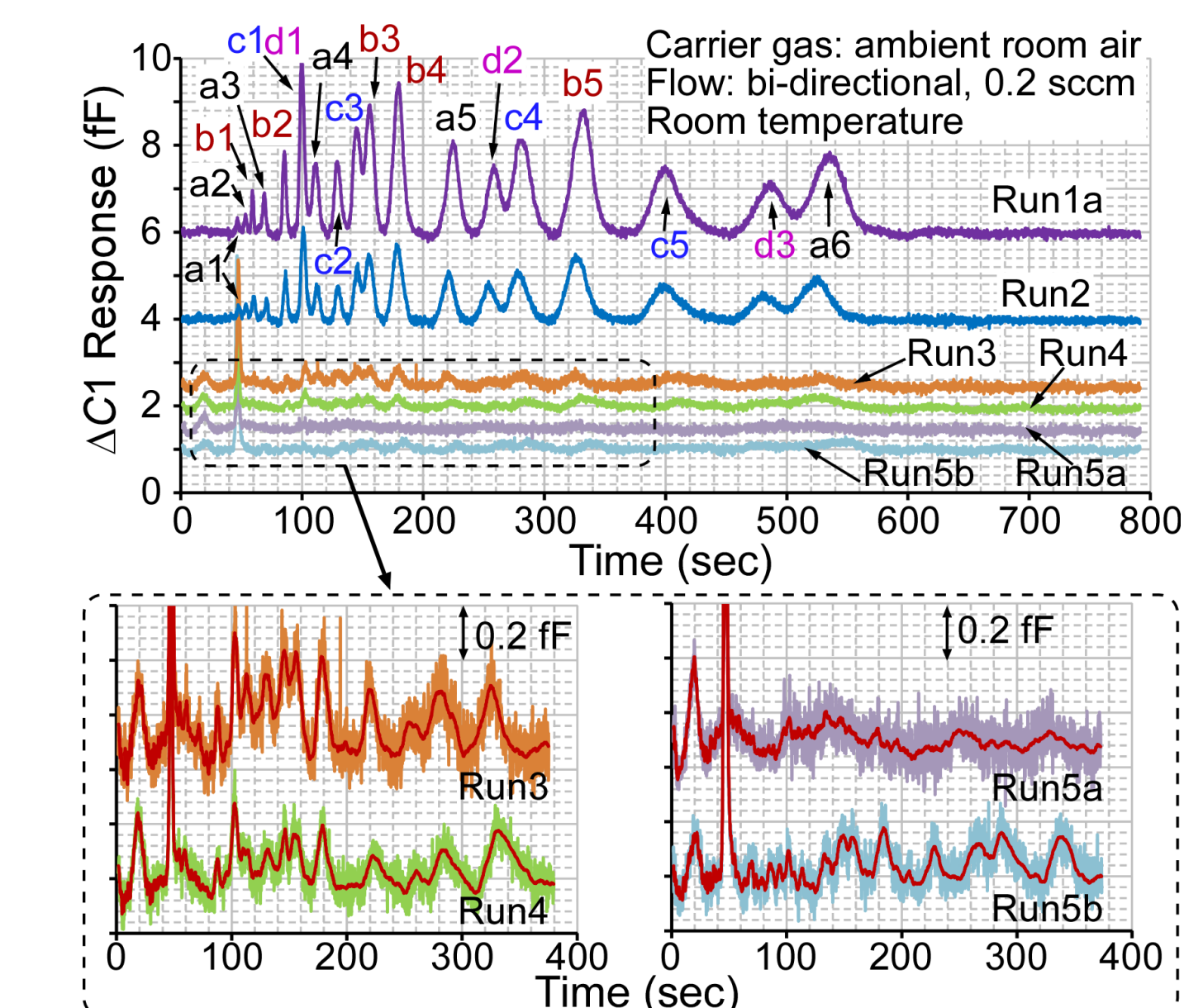


IOP JMM, 2014

2

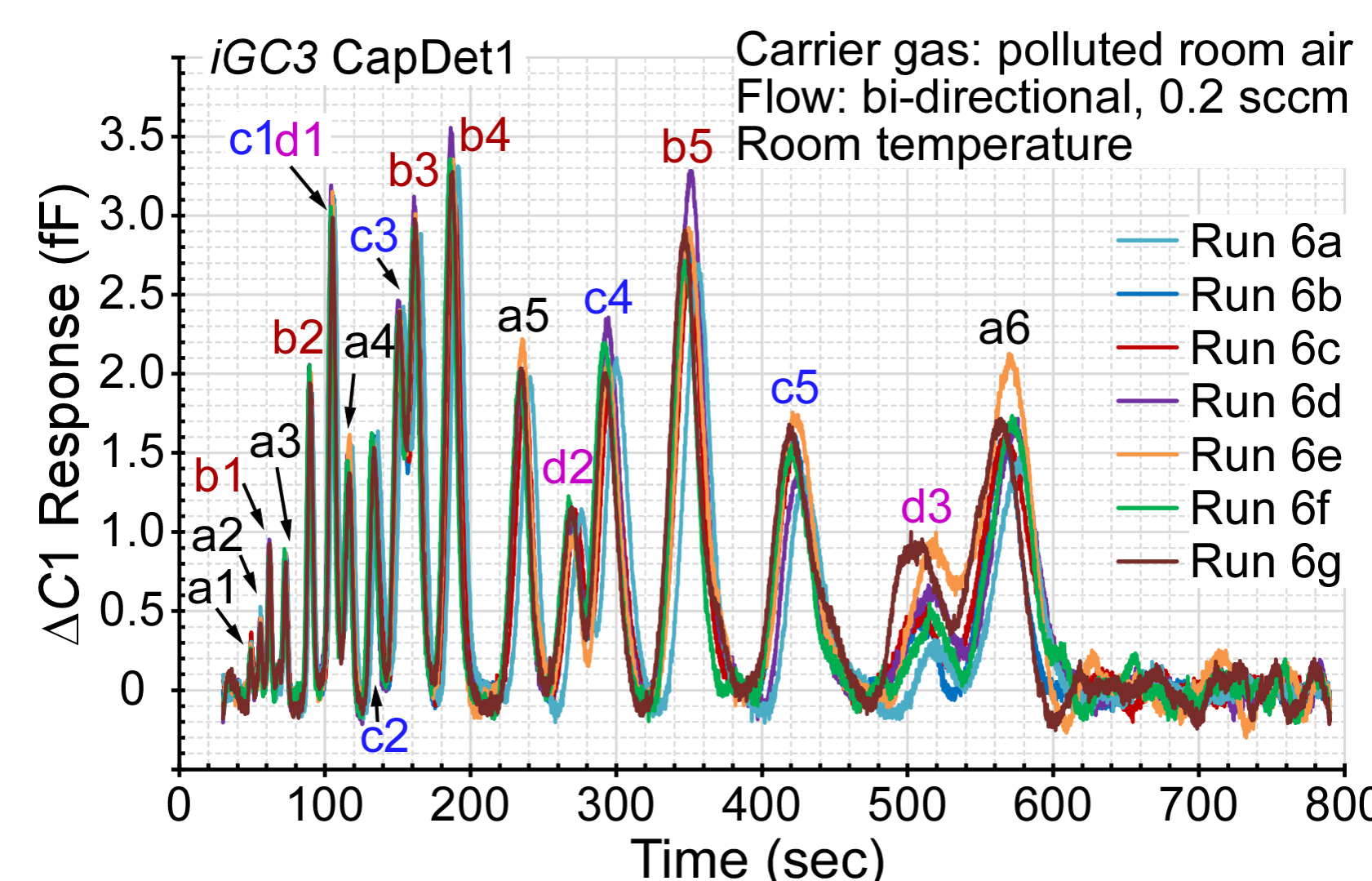
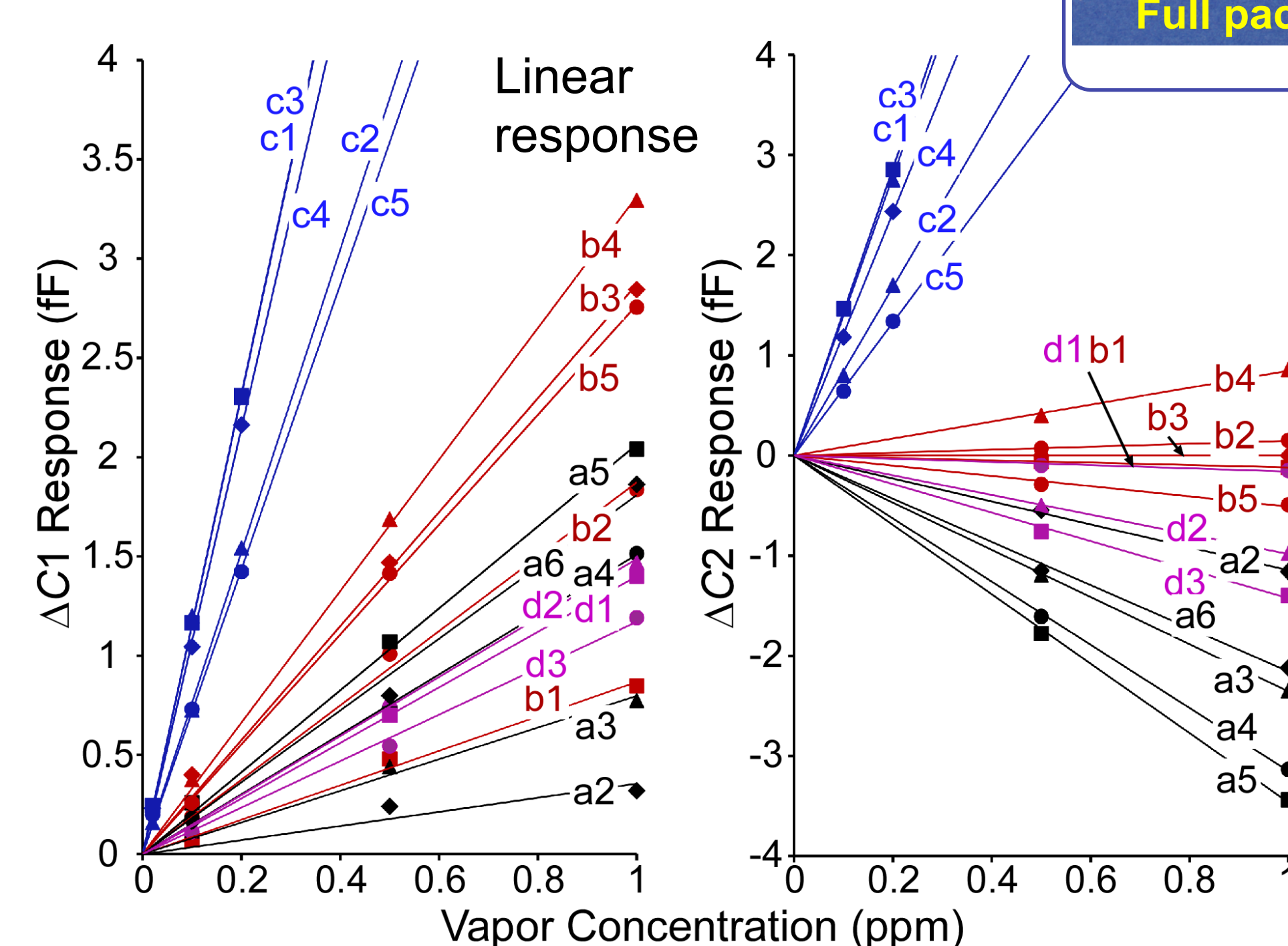
- 19 chemicals
- BTX and other indoor pollutants
- ppb-ppm concentrations

Run ID:			1	2	3	4	5
			1a				5a 5b
Chemicals		Polarity	Concentration (ppm)				
a1	pentane C5	nonpolar	1	0.5	20	10	10
a2-a6	n-alkanes C6-C9	nonpolar	1	0.5	0.1	0.05	0.01
b1-b5	benzene, toluene, m-xylene, o-xylene, mesitylene	nonpolar	1	0.5	0.1	0.05	0.01
c1-c5	hexanal, chlorobenzene, chlorohexane, 4-chlorotoluene, 1,3-dichlorobenzene	mildly polar	0.2	0.1	0.02	0.01	0.002
d1-d3	cycloheptane, α-pinene, 3-carene	nonpolar	1	0.5	0.1	0.05	0.01
Sampling time (min.)				30			120

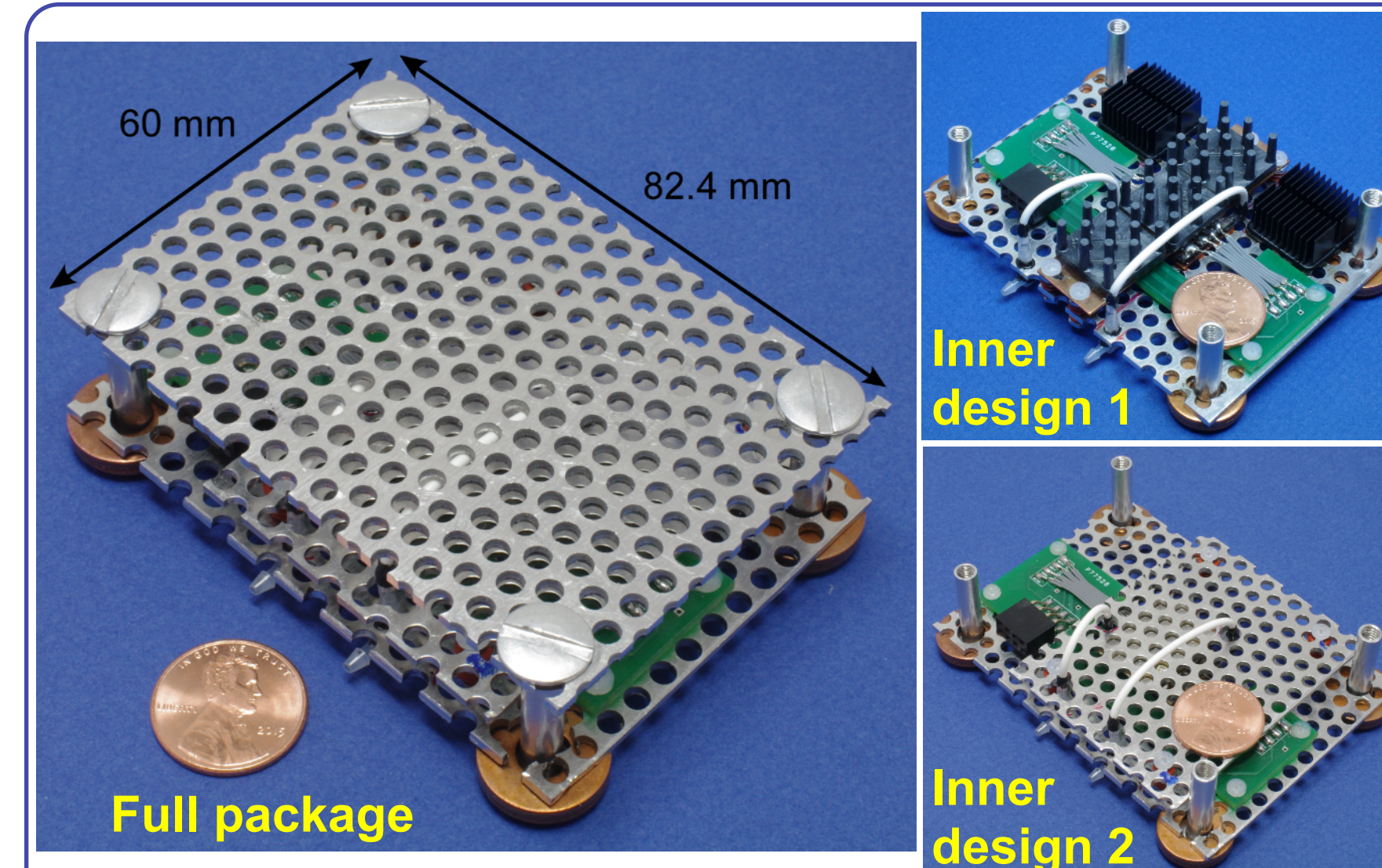


CapDet1 : + peak to all chemicals

CapDet2 : +/- peak to different chemicals



Repeatable analysis using polluted air sample with 10-50% humidity as carrier gas  
Mimicking unattended field monitoring scenarios



Metrics (for <i>iGC3</i> separation)	<i>iGC3</i> 2- stage pump	New 1- stage pump
Blocking pressure	1 kPa	0.85 kPa
Max. flow	0.5 sccm	0.6 sccm
System flow	0.2 sccm	0.2 sccm
Power	3.2 W	2 W

- Simpler manufacturing
- Greater power efficiency

IEEE MEMS. 2017

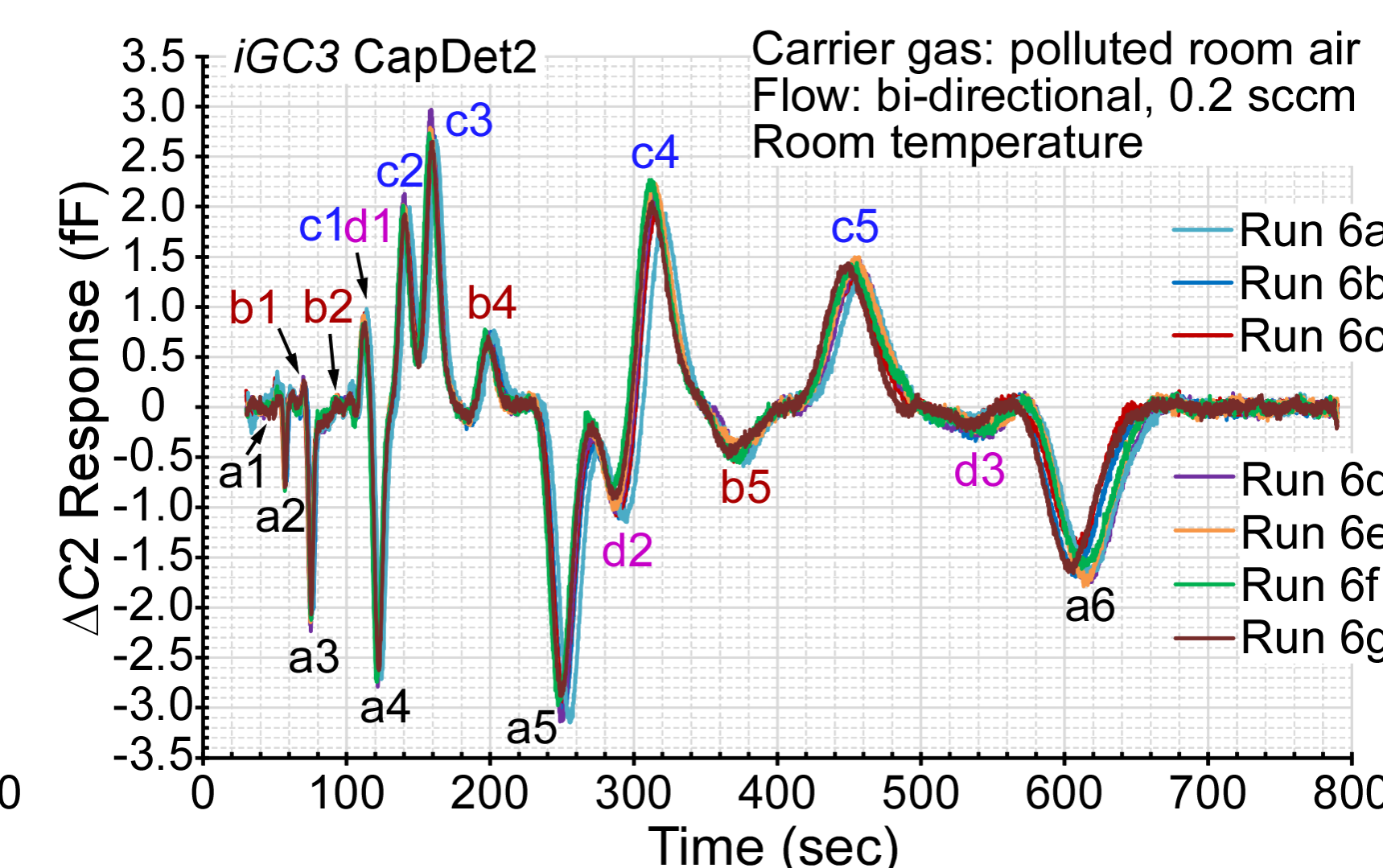
- Indoor pollutants

**Potential applications:**

- Outdoor pollutants
- Automobiles
- Ground water
- Soundless surveillance
- Medical

- 30 compounds within *iGC3* range
- 7 compounds tested in *iGC3*

1. Dichlorodifluoromethane
2. Methyl Chloride
3. 1,2-dichloro-1,1,2,2-tetrafluoroethane
4. Vinyl Chloride
5. Methyl Bromide
6. Ethyl Chloride
7. Trichlorofluoromethane
8. 1,1-dichloroethene
9. Dichloromethane
10. 3-chloropropene
11. 1,1,2-trichloro-1,2,2-trifluoroethane
12. 1,1-dichloroethane
13. Cis-1,2-dichloroethene
14. Trichloromethane
15. 1,2-dichloroethane
16. 1,1,1-trichloroethane
17. Benzene
18. Carbon Tetrachloride
19. 1,2-dichloropropane
20. Trichloroethene
21. Cis-1,3-dichloropropene
22. Trans-1,3-dichloropropene
23. 1,1,2-trichloroethane
24. Toluene
25. 1,2-dibromoethane
26. Tetrachloroethene
27. Chlorobenzene
28. Ethylbenzene
29. m,p-xylene
30. Styrene
31. 1,1,2,2-tetrachloroethane
32. o-xylene
33. 4-ethyltoluene
34. 1,3,5-trimethylbenzene
35. 1,2,4-trimethylbenzene
36. m-dichlorobenzene
37. Benzyl Chloride
38. p-dichlorobenzene
39. o-dichlorobenzene
40. 1,2,4-trichlorobenzene
41. Hexachlorobutadiene



*Publications:*

- [1] Y. Qin, Y.B. Gianchandani, "iGC2: an architecture for micro gas chromatographs utilizing integrated bi-directional pumps and multi-stage preconcentrators," *IOP Journal of Micromechanics and Microengineering*, vol. 24, no. 6, 065011(10 pp.), 2014.
- [2] Y. Qin, Y. Gianchandani, "A Fully Electronic Microfabricated Gas Chromatograph with Complementary Capacitive Detectors for Indoor Pollutants," *Nature Microsystems and Nanoengineering*, vol. 2, 15049(11 pp.), 2016, (Featured Article)
- [3] Q. Cheng, Y. Qin, Y.B. Gianchandani, "A Bidirectional Knudsen pump with Superior Thermal Management for Micro-Gas Chromatography Applications," *IEEE International Conference on Micro Electro Mechanical Systems (MEMS)*, Las Vegas, Nevada, Jan.

*Patent:* Y.B. Gianchandani, Y. Qin, “Integrated Fluidic System for Gas Chromatography,” US 61/824,573, patent pending

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